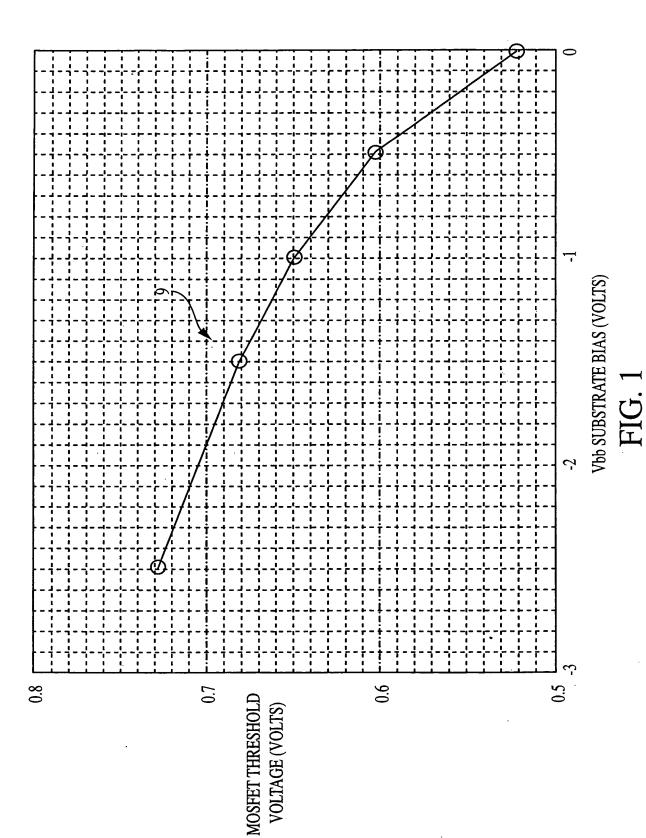
Docket No.: M4065.0227/P227

App No.: 09/652,216 Docket No.: M4065 Inventor: Tongbi Jiang et al. Title: METHOD AND APPARATUS FOR REDUCING SUBSTRATE BIAS VOLTAGE DROP

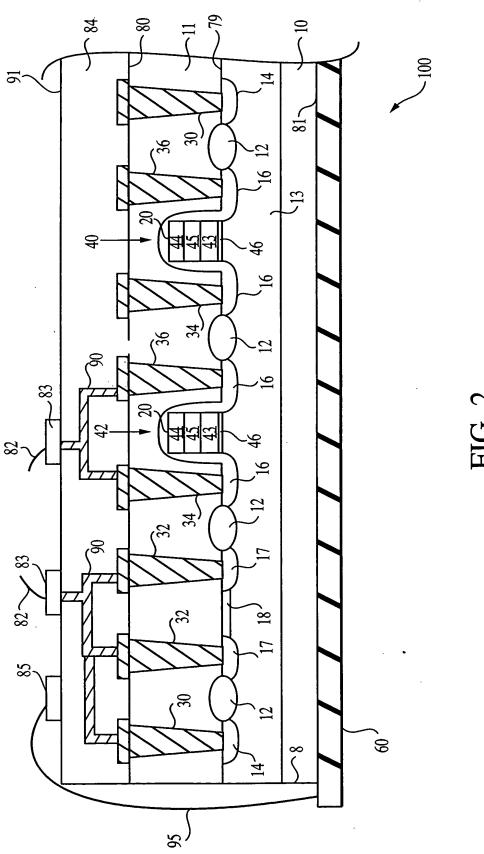




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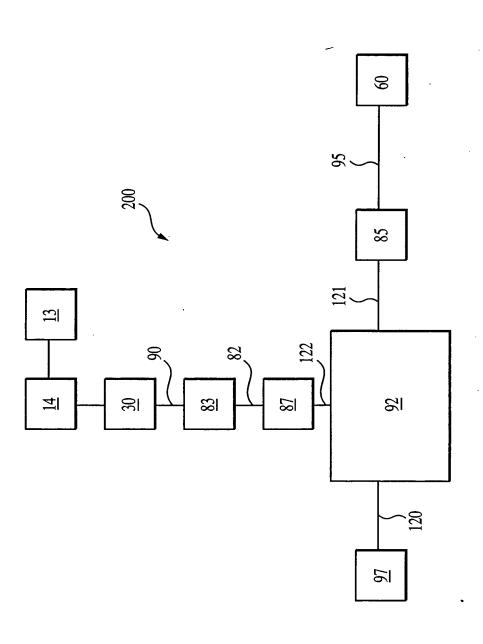




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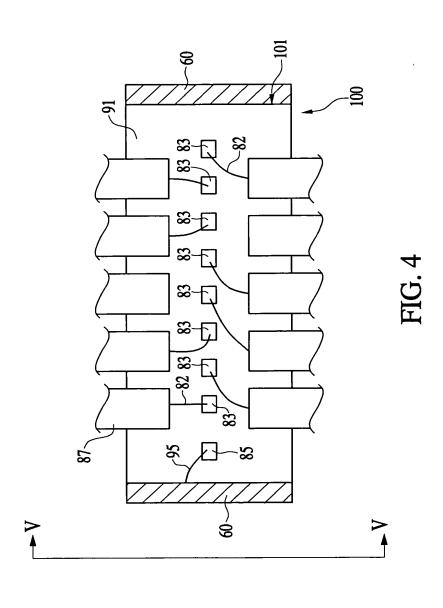




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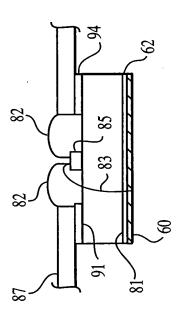




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